WHAT IS CLAIMED IS:

- 1 1. A method of correcting laser beam intensity, comprising
- 2 the steps of:
- 3 rotating an optical substrate around an optical axis
- 4 of a laser beam as a rotation axis while maintaining an
- 5 incident angle of the laser beam thereto, the optical
- 6 substrate being located in a manner that the incident angle
- 7 of the laser beam is set at a Brewster's angle; and
- 8 controlling transmission intensity of the laser beam.
 - 1 2. A method of correcting laser beam intensity by using
- 2 laser beam intensity correcting mechanism including a
- 3 plurality of optical paths, a rotation cylinder being
- 4 rotated around an optical axis of the laser beam as a rotation
- 5 axis arranged in at least one of the plurality of optical
- 6 paths and an optical substrate fixed at a predetermined
- 7 slope angle with respect to the optical axis provided in
- 8 the rotation cylinder, comprising a step of:
- 9 rotating the rotation cylinder to rotate the optical
- 10 substrate around the optical axis as the rotation axis while
- 11 maintaining the slope angle.
 - 1 3. The method of correcting laser beam intensity according
 - 2 to claim 2, further comprising a step of:
 - adjusting the laser beam intensity in each optical
 - 4 path to be equal to others.

- A laser beam intensity correction mechanism including 1
- an optical substrate rotating around an optical axis of 2
- a laser beam as a rotation axis while maintaining an incident 3
- angle, the optical substrate being located in a manner that 4
- the incident angle of the laser beam is set at a Brewster's 5
- angle, wherein transmission intensity of the laser beam 6
- 7 is varied by rotating the optical substrate.
- 5. A laser beam intensity correction mechanism according
- to claim 4, wherein the optical substrate is made of a quartz
 - plate.

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- A laser beam intensity correction mechanism according 1
- thing they there there is to claim 4, wherein an antireflection coating is formed 2
 - on at least one surface of the optical substrate. 3
 - 7. A laser beam intensity correction mechanism comprising 1
 - a rotation cylinder being rotated around an optical axis 2
 - of a laser beam as a rotation axis and an optical substrate 3
 - fixed at a predetermined slope angle with respect to the
 - optical axis of the laser beam in the rotation cylinder, 5
 - wherein the optical substrate is rotated around the optical 6
 - axis as the rotation axis while maintaining the slope angle 7
 - 8 by rotating the rotation cylinder.
 - 8. A laser beam intensity correction mechanism according 1

- to claim 7, wherein the slope angle of the optical substrate $% \left(1\right) =\left(1\right) \left(1\right)$ 2
- is set in a manner that the incident angle of the laser 3
- beam is set at the Brewster's angle.
- 1 9. A laser beam intensity correction mechanism comprising
- a plurality of optical paths for a plurality of laser beams, 2
- a rotation cylinder provided in at least one of the plurality 3
- of optical paths, the rotation cylinder being rotated 4
- around an optical axis of the laser beam as a rotation axis, 5
- and an optical substrate fixed at a predetermined slope
 - angle with respect to the optical axis of the laser beam
- provided in the rotation cylinder, wherein the optical
 - substrate is rotated around the optical axis as the rotation
- axis while maintaining the slope angle by rotating the
 - rotation cylinder.

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- 10. A laser beam intensity correction mechanism according 1
- to claim 9, wherein the slope angle of the optical substrate 2
- is set such that the incident angle of the laser beam is 3
- 4 set at the Brewster's angle.
- 1 A laser generating device comprising a laser beam
- source, an optical part for splitting the laser beam emitted 2
- from the laser beam source into a plurality of optical paths 3
- and correcting means for correcting laser beam intensity, 4
- 5 the correcting means being provided in at least one of
- 6 the optical paths, wherein the correcting means includes

- 7 a rotation cylinder being rotated around an optical axis
- 8 of the laser beam as a rotation axis in the case and an
- 9 optical substrate slantly fixed such that the incident
- 10 angle of the laser beam is set at the Brewster's angle.
- 1 12. A laser generating device according to claim 11,
- 2 wherein the correcting means is provided in an optical path
- 3 except a reference optical path.